

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional)		Application Number	
				44802-0193		10/532,845	
				Applicant(s)			
				Jiuhuai Lu et al.			
Filing Date <b>April 27, 2005</b>				Group Art Unit <b>2621</b>			
<b>U. S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>U. S. PATENT APPLICATION PUBLICATIONS</b>							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		2001/0010733	8.2.2001	Tomomatsu			
		2002/0018054	2.14.2002	Tojima et al.			
<b>FOREIGN PATENT DOCUMENTS</b>							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	1020010001458	1.5.2001	Korea w/English Abstract			X	
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
	Korean Application No. 1020057010319 Office Action dated December 20, 2010, 2 pages						
EXAMINER		/Y Lee/		DATE CONSIDERED		02/25/2011	
<b>EXAMINER:</b> Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							